

Our Docket No: 42P11370



1756

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Takeshi Ohfuji et al.

Serial No: 09/965,280

Filed: September 26, 2001

For: Post Exposure Modification
Of Critical Dimensions In
Mask Fabrication

Examiner: Mohamedulla, S.

Art Unit: 1756

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RESPONSE TO OFFICE ACTION

Mail Stop Non-Fee Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Office Action mailed March 11, 2004, the Applicants respectfully request that the Examiner enter the following amendments and consider the following remarks.

FIRST CLASS CERTIFICATE OF MAILING

I hereby certify that I am causing the above-referenced correspondence to be deposited with the United States Postal Service as first class mail with sufficient postage on the date indicated below and that this paper or fee has been addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313

April 9, 2004
Date of Deposit

Krista Mathieson
Name of Person Mailing Correspondence

Krista Mathieson
Signature

April 9, 2004
Date